EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	607888	@rlad<"19960715"	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:30
L2	2338516	@ad<"19960715"	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:30
L3	2452932	l1 or l2	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:34
L4	14095	(workpiece or substrate) adj holder	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:35
L5	1557238	rotate or rotates or rotated or rotating or rotation	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:35
L6	2941	l4 with l5	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:35
L7	874534	vessel or tank or bath	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:37
L8	201	l7 same l6	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:38
L9	647436	semiconductor or wafer	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:38
L10	163	l8 and l9	US-PGPUB; USPAT	ADJ	ON	2006/10/13 15:38
L11	25	l10 and l3	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:01
L12	22	(l8 and l3) not l11	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:18
L13	20709	(workpiece or substrate) adj support	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:47
L14	1512	l13 with l5	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:47
L15	79	l14 same l6	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:47
L16	16	l15 and l3	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:48
L17	15	l16 not (l11 or l12)	US-PGPUB; USPAT	ADJ	ON	2006/10/13 16:48